



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 13, 2026	
IGI Report Number	LG831682850
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	6.69 X 4.81 X 3.37 MM

GRADING RESULTS

Carat Weight	1.04 CARAT
Color Grade	E
Clarity Grade	VVS 2

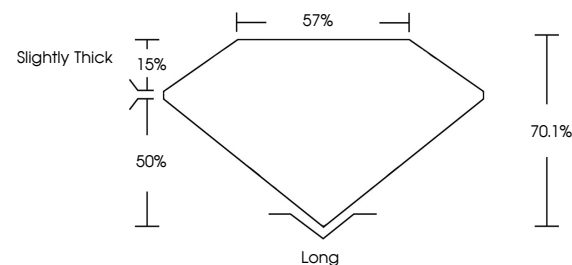
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG831682850

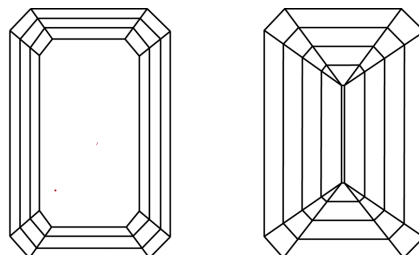
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG831682850
Report verification at [igi.org](https://www.igi.org)

PROPORTIONS

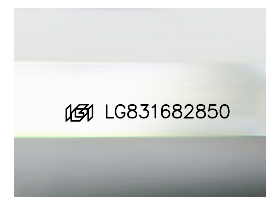


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

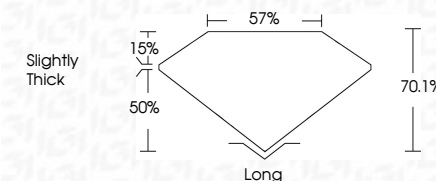
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October 13, 2026	1.04 CARAT
GI Report No LG33 162850	E
HERAUD CUT	VVS 2
	70.1%
	57%
	Slightly Thick
	Long
	EXCELLENT
	EXCELLENT
	NONE
	681 LG33 162850

Comments: This is a very young diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa